

Thin films with nanometer-scale pillar microstructure

Journal of Materials Research

14, 3158-3163

DOI: 10.1557/jmr.1999.0423

Citation Report

#	ARTICLE	IF	CITATIONS
1	Periodic magnetic microstructures by glancing angle deposition. Journal of Vacuum Science and Technology A: Vacuum, Surfaces and Films, 2000, 18, 1838-1844.	2.1	90
2	Porous thin films for thermal barrier coatings. Surface and Coatings Technology, 2001, 138, 185-191.	4.8	59
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5	Periodic submicrometer structures by sputtering. Journal of Vacuum Science & Technology an Official Journal of the American Vacuum Society B, Microelectronics Processing and Phenomena, 2001, 19, 1813.	1.6	49
6	Microsprings and microcantilevers: studies of mechanical response. Journal of Micromechanics and Microengineering, 2001, 11, 582-588.	2.6	51
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12	Investigation of substrate rotation at glancing incidence on thin-film morphology. Journal of Vacuum Science & Technology an Official Journal of the American Vacuum Society B, Microelectronics Processing and Phenomena, 2003, 21, 2569.	1.6	57
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